Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/676,961	PON ET AL.	
Examiner	Art Unit	
Chris C. Chu	2815	

SEARCHED				
Class	Subclass	Date	Examiner	
257	723, 686, 685, 646, 693 & 777	12/27/2004	C.C.	
257	784 & 786	12/27/2004	C.C.	
257	676	12/27/2004	C.C.	
361	760 _	12/27/2004	C.C.	
438	108 & 109	12/27/2004	C.C.	
438	612	12/27/2004	C.C.	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Searched in US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; and IBM_TDB;	12/27/2004	C.C.